



[10191/1993]

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant : Richard SPITZ et al.  
Serial No. : 09/914,404  
Filed : December 13, 2001  
For : **METHOD FOR PRODUCING HEAVILY-DOPED  
SEMICONDUCTOR COMPONENTS**  
  
Group Art Unit : 2823  
Confirmation No. : 5115  
Examiner : Michelle Estrada

MAIL STOP RCE  
Commissioner For Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT AFTER FINAL OFFICE ACTION**

S I R:

In response to the Final Office Action mailed on May 2, 2003 (and the Advisory Action mailed on October 2, 2003) (the response date for which has been extended to November 3, 2003 (since November 2, 2003 is a Sunday) by the accompanying RCE and Petition To Extend), please reconsider the above-identified application based on the following:

**Amendments to the Claims** are reflected in the listing of the claims which begins on page 2 of this paper.

**Remarks** begin on page 7 of this paper.

11/03/2003 BABRAHA1 00000119 110600 09914404

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